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# TRANSMITTAL FORM

*(to be used for all correspondence after initial filing)*

Application Number	09/632,425
Filing Date	August 4, 2000
First Named Inventor	Geiger, Fabrice
Group Art Unit	2829
Examiner Name	Lisa A. Kilday
Total Number of Pages in This Submission	Attorney Docket Number
	A3024/T28300

**ENCLOSURES (check all that apply)**

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| <input type="checkbox"/> Response to Missing Parts under 37 CFR 1.52 or 1.53 |   | The Commissioner is authorized to charge any additional fees to Deposit Account 20-1430.             |

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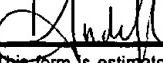
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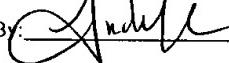
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TOWNSEND and TOWNSEND and CREW LLP

By: 



AMENDMENT UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE -  
EXAMINING GROUP 2829

PATENT  
Attorney Docket No.: A3024/T28300  
TTC Ref. No.: 16301-028300

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of:

Fabrice Geiger et al.

Application No.: 09/632,425

Filed: August 4, 2000

For: PROCESS FOR DEPOSITING A  
POROUS, LOW DIELECTRIC  
CONSTANT SILICON OXIDE FILM

Examiner: Lisa A. Kilday

AMENDMENT UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE EXAMINING  
GROUP 2829

**Box AF**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

In response to the Final Office Action mailed December 11, 2002, please amend this application as follows:

**IN THE SPECIFICATION:**

Page 17, TABLE 2, please change "500 Å/min" to --5500 Å/min--.

Page 17, please delete footnotes 1 and 2.

Page 17, lines 2-7, please amend the paragraph as follows:

From Table 2, if the underlayer is thermal oxide then the deposition rate is lower, the wet etch rate is significantly higher, the surface roughness worse, and the stress hysteresis, in a room temperature to 360°C heat cycle, is higher than an underlayer

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